



10/784,619

PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Patent Application of

Jon Opsal (AS AMENDED)

Application No.: 10/784,619

Filed: February 23, 2004

For: GLOBAL SHAPE DEFINITION  
METHOD FOR SCATTEROMETRY

Group Art Unit: 2877

Examiner: Unknown

**PRELIMINARY AMENDMENT**

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Commissioner for Patents  
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STALLMAN & POLLOCK LLP

Dated: 05/27/2004

By:

*Georgia K. Stith*  
Georgia K. Stith

Sir:

Please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.